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Attn: Mail Stop Amendment

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Re:

U.S. Utility Patent Application

Application No. 10/811,070; Filing or 371(c) Date: March 29, 2004 For: Lithographic Apparatus and Device Manufacturing Method

Inventors: Van Der Feltz et al.

Our Ref: 1857.2780000

Sir:

Transmitted herewith for appropriate action is the following document:

1. Amendment & Reply Under 37 C.F.R. § 1.111 Responsive to Office Action dated October 31, 2008.

The above-listed document is being filed electronically through EFS-Web.

In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

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JDE/SHS/jdp Enclosure(s) 925180.vl